



Attorney's Docket No.: 4733 USA D01/TSG/TPG/RKK

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of: )

Steven Verhaverbeke et al. )

U.S. Serial No: 10/616,093 )

Filed: July 8, 2003 )

For: ASSISTED RINSING IN A SINGLE )  
WAFER CLEANING PROCESS )

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Examiner: Markoff, Alexander

Art Unit: 1746

AMENDMENT AND RESPONSE

Dear Sir:

This is in response to the Final Office Action mailed October 19, 2005 and the Request for Continued Examination (RCE) under 37 C.F.R. § 1.114 filed concurrently herewith. Applicant respectfully requests the Examiner to enter this Preliminary Amendment and consider the following remarks.

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to MAIL STOP RCE

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U.S. Patent and Trademark Office, Washington, D.C. 20231 on Tuesday, February 21, 2006

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